



PATENT 2691-000013/US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Kohshi TAGUCHI et al.

Conf. No.:

Unknown

Application No.:

10/520,815

Group No.:

Unknown

Filing Date:

January 7, 2005

Examiner:

Unknown

For:

METHOD AND APPARATUS FOR FORMING SILICON NITRIDE

FILM

Customer Service Window Randolph Building 401 Dulany Street Alexandria, VA 22314 February 22, 2005

ASSERTION OF SMALL ENTITY STATUS

Sir:

The above-identified application qualifies for small entity status. This written assertion of small entity status should satisfy the requirements of 37 C.F.R. § 1.27.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 08-0750 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17;

particularly, extension of time fees.

Respectfully submitted,

HARNESS, DICKEY, & PIERCE, P.L.C.

Bv

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